



(PCL)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hirofumi WATATANI**

Group Art Unit: **1765**

Serial No.: **10/685,790**

Examiner: **Kin Chan Chen**

Filed: **October 16, 2003**

Confirmation Number: **7016**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR
DEVICE MANUFACTURING METHOD**

Attorney Docket Number: **032015**
Customer Number: **38834**

AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

August 16, 2005

Sir:

In response to the Office Action dated May 18, 2005, Applicant amends the claims as follows and submits the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 7 of this paper.